



EFK

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78925

Hiroyuki IWASHITA, et al.

Appln. No.: 10/727,045

Group Art Unit: 3753

Confirmation No.: 4829

Examiner: Kevin L. Lee

Filed: December 4, 2003

For: CLEANING VALVE DRIVE UNIT

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 17, 2006, please amend the above-identified application as follows on the accompanying pages.